

Method and Device for Prefixing Substrates

Abstract

This invention relates to a method and a device for prefixing substrates (1, 2), whereby at least one substrate surface (1o, 2o) of the substrates (1, 2) is amorphized in at least one surface area, characterized in that the substrates (1, 2) are aligned and then make contact and are prefixed on the amorphized surface areas.

Figure 2.